

List of Content

List of Figures.....	9
List of Tables	15
Abstract	19
1 Motivation	21
2 Introduction to Polymer Brushes.....	27
2.1 Surface Initiated Polymerization (SIP)	28
2.1.1 Photoiniferter-mediated Polymerization (PMP)	28
2.1.2 Atom Transfer Radical Polymerization (ATRP)	29
2.2 Self-Assembled Monolayer (SAM)	31
2.3 SAMs by Micro-Contact Printing (μ -CP)	32
2.4 Variation of Polymer Brushes.....	35
2.4.1 Grafting Density	35
2.4.2 Cross-linking Density.....	36
3 Characterization Methods	37
3.1 Contact Angle (CA) Measurements	37
3.2 Fourier Transform Infrared (FTIR) Spectroscopy	39
3.3 Atomic Force Microscopy (AFM)	39
4 Experimental Part	43
4.1 Materials.....	43
4.1.1 Initiator.....	43
4.1.2 Polymers.....	44
4.2 Preparation.....	45
4.2.1 Preparation of Gold Substrates.....	45
4.2.2 SAMs.....	47
4.2.3 Micro-Contact Printing (μ -CP).....	47
4.2.4 Preparation of Polymer Brushes.....	48

4.3	Characterization	49
4.3.1	Contact Angle (CA) Measurements	49
4.3.2	Ellipsometry.....	50
4.3.3	Fourier Transform Infrared (FTIR) Spectroscopy	50
4.3.4	Atomic Force Microscope (AFM)	51
5	Results and Discussion	53
5.1	Polymer Brushes	53
5.1.1	Polymerization Kinetics	53
5.1.2	Grafting Density	60
5.1.3	Cross-linking Density.....	68
5.2	Polymer Brush Analysis by AFM.....	72
5.2.1	Surface Morphology	74
5.2.2	Thickness	81
5.2.3	Wettability	84
5.2.4	Mechanical Properties.....	87
6	Discussion, Conclusions and Outlook.....	99
7	References	103
8	Appendix	107
8.1	PAAm Brushes via PMP	107
8.1.1	Iniferter.....	107
8.1.2	Modification of Silicon Substrates with Iniferter.....	110
8.1.3	Construction of the UV-LED setup	112
8.1.4	Preparation of Polymer Brushes	113
8.2	PAAm Brushes via ATRP	115